



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Shunpei YAMAZAKI) Group Art Unit: 2814
Serial No. 09/620,968)
Filed: July 20, 2000) Examiner: Nathan W. Ha
For: METHOD OF FORMING INSULATING FILMS,)
CAPACITANCES, AND SEMICONDUCTOR) Confirmation No.: 4214
DEVICES)

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following is presented in response to the Office Action mailed October 8, 2003, in connection with the above-captioned patent application.